Docket No.: 49657-871

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

-Masaĥiko TAKEUCHI, et al.

Serial No.:

Group Art Unit:

Filed: November 30, 2000

Examiner:

For:

PHOTOMASK INCLUDING AUXILIARY MARK AREA, SEMICONDUCTOR

DEVICE AND MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Please note that U.S. Patent 5,750,433 is a counterpart of Japanese Patent 10-22376.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Gene Z. Rubinson

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#3 DDUM 6-28-01 SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 49657-871		SERIAL NO	i	853 1853 1000	
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(PTO-1449)				FILING DATE November 30, 2000		GROUP). D		
EXAMINER'S	Т		U.S. PATENT	DOCUMENTS	3	<u> </u>			
INITIALS	PATENT NO.	DATE	NAME		CLASS SUBCLASS		FILING DATE		
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EXAMINER'S		FO	REIGN PATEN	T DOCUMEN	TS				
INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS		Translation Yes No.	
	10-22376	1/23/98	Japan				103	No	
	60-15944	1/26/85	Japan (with English abstract)						
	63-250148	10/18/88	Japan (with English abstract)						
	58-70528	4/27/83	Japan (with English abstract)						
	9-260446	10/3/97	Japan (with English abstract)						
	60-211941	10/24/85	Japan (with English abstract)						
	63-262835	10/31/88	Japan (with En	glish abstract)					
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